



PRODUCTION METHOD OF SEMICONDUCTOR DEVICE

Inventor: Yoshiyuki Tanaka et al.

Docket No. 075834.00111

Robert J. Depke, Holland & Knight LLC - (312) 263-3600

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FIG.4A

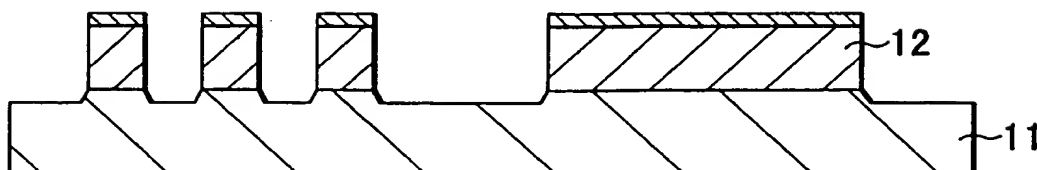
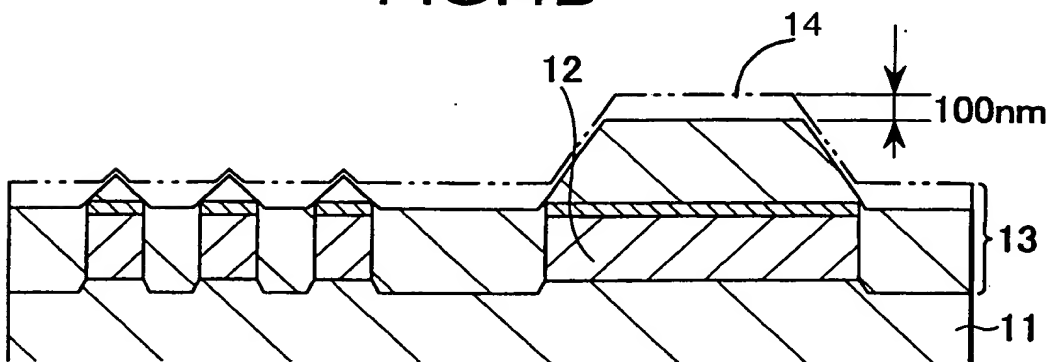


FIG.4B

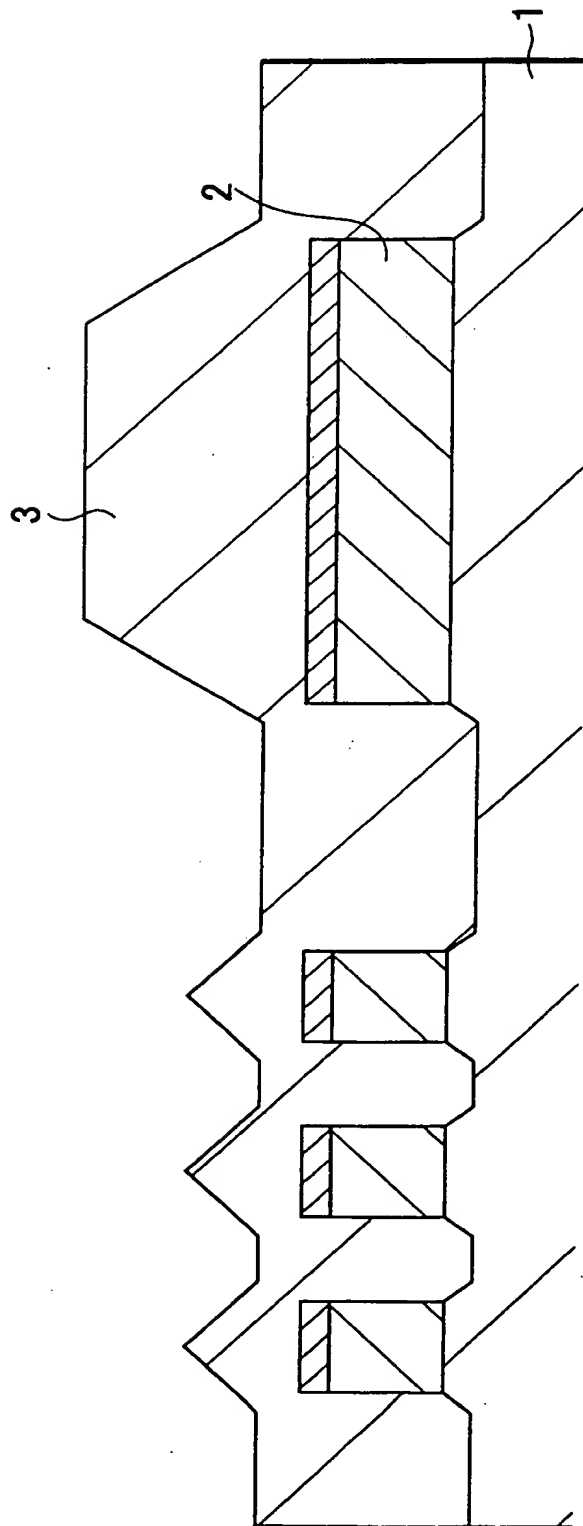




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FIG.6





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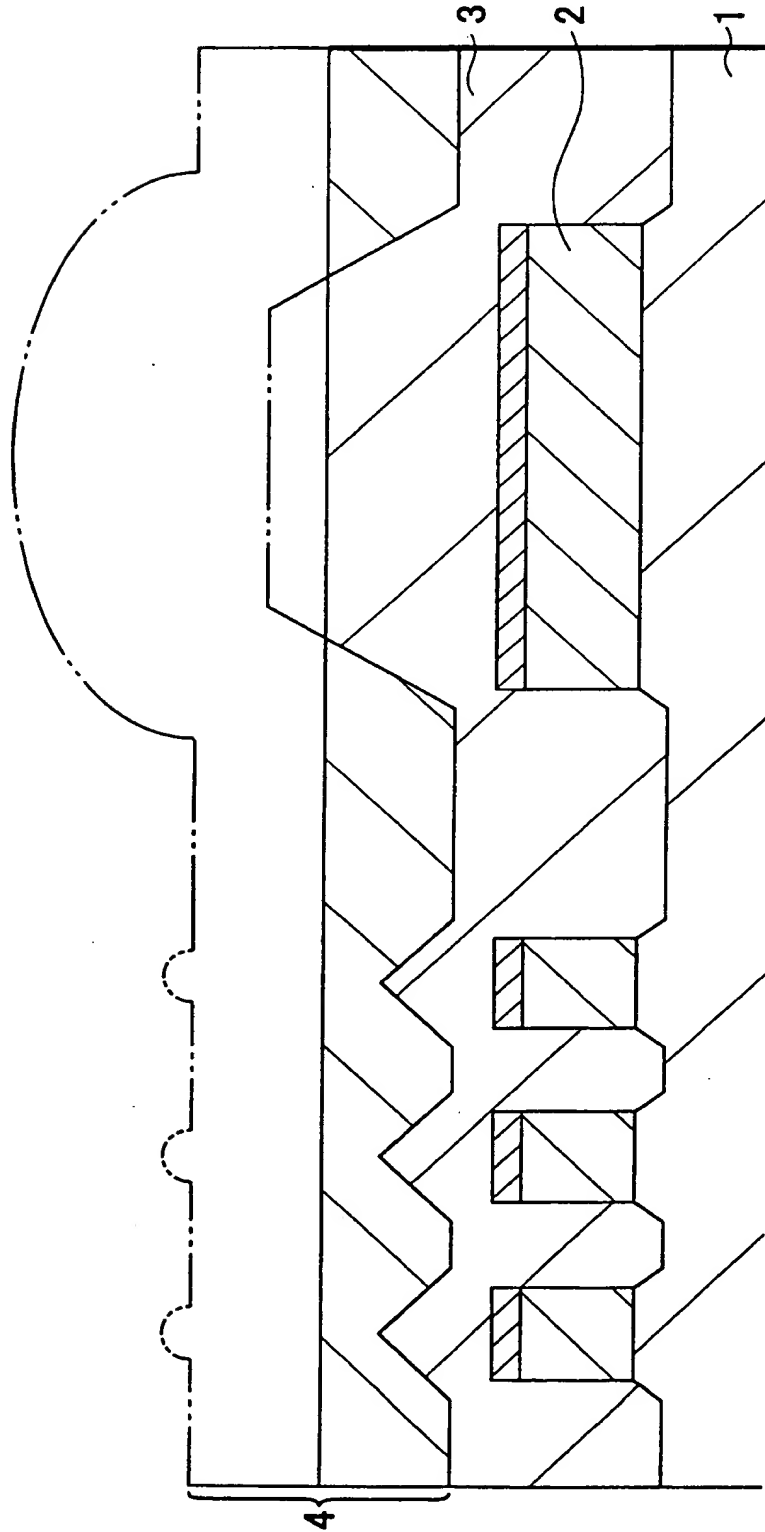
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FIG.7

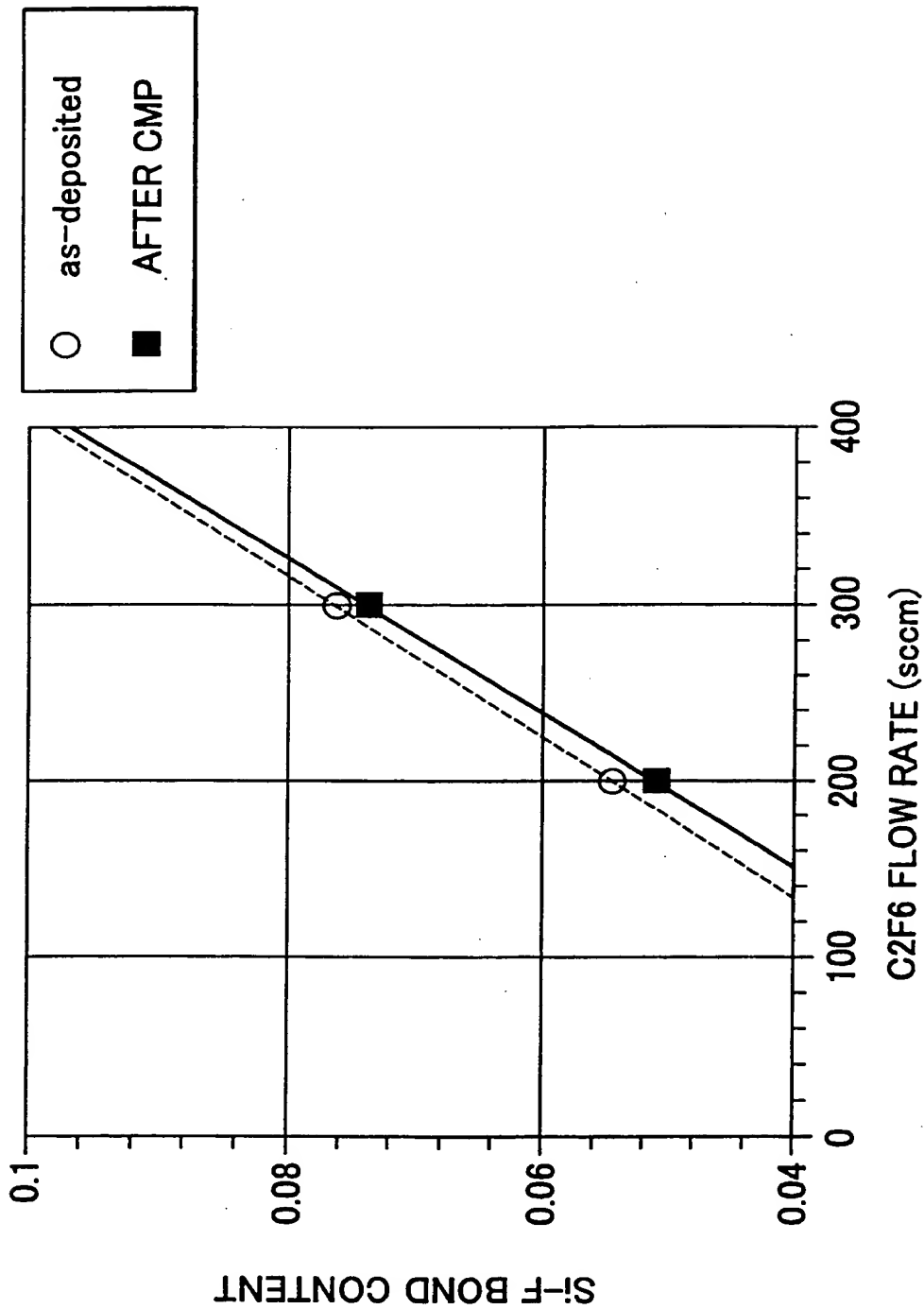




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FIG.8

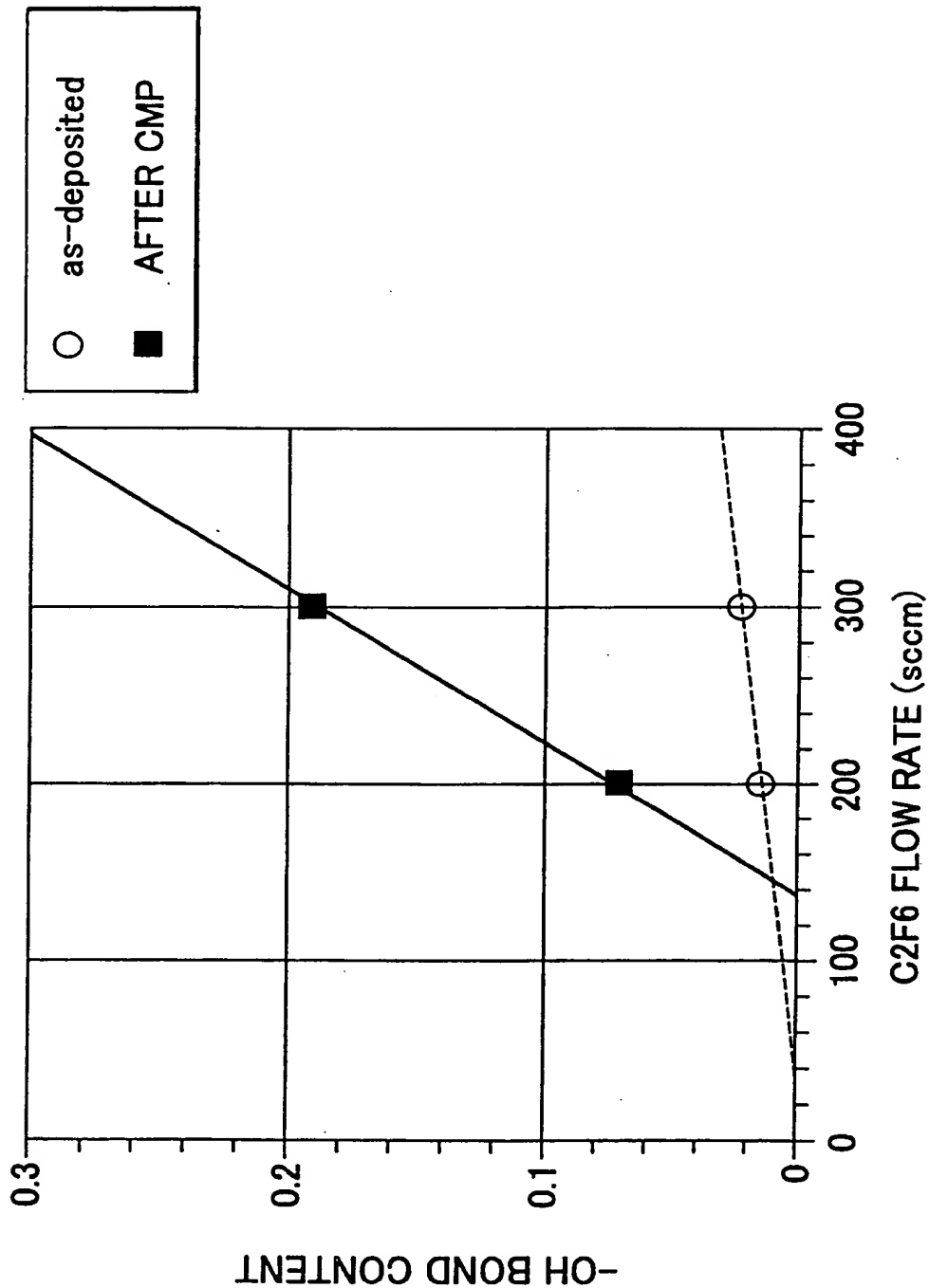




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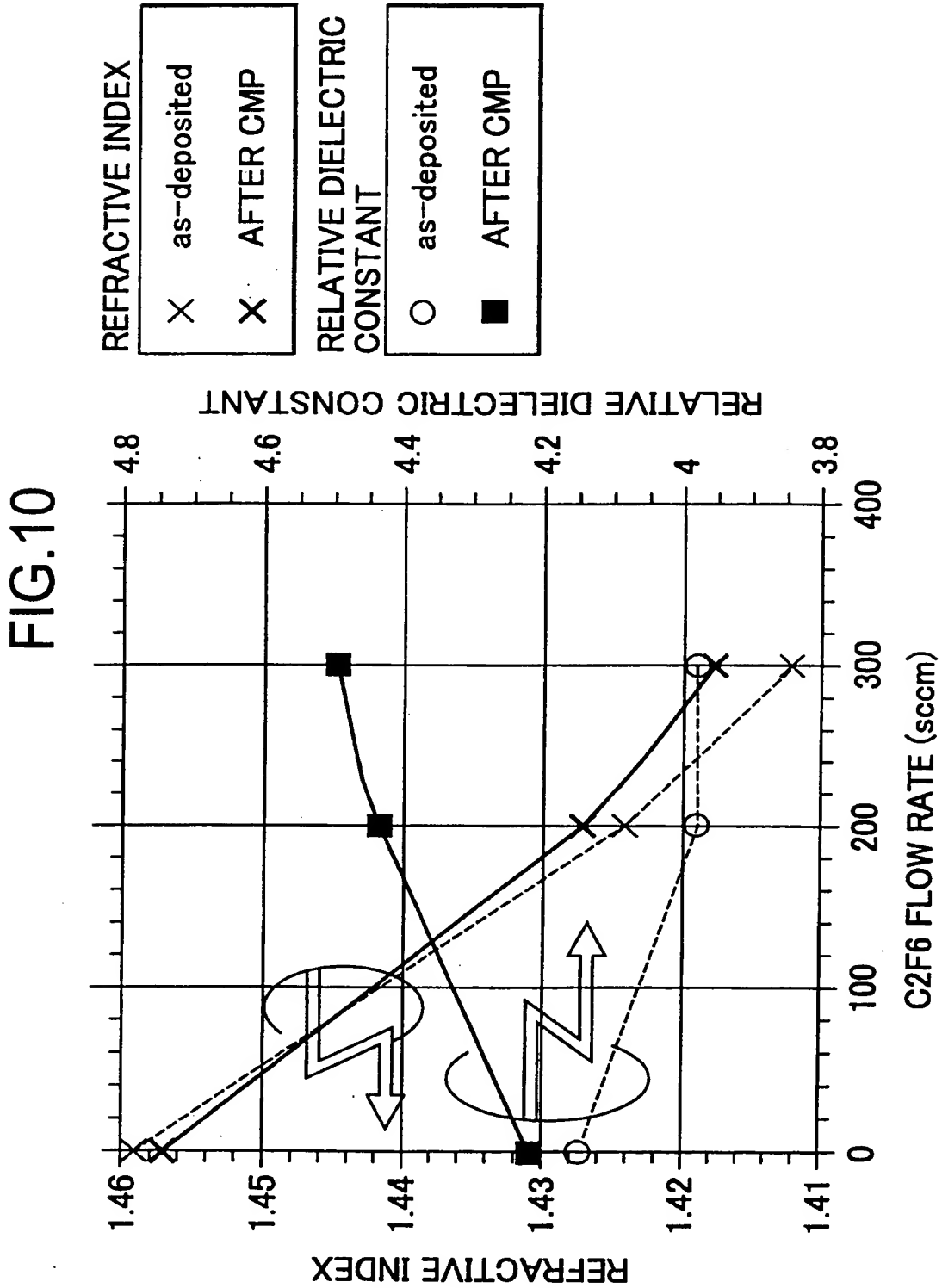
FIG.9





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FIG. 11

